



03500.016072.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: Unassigned
MINEO SHIMOTSUSA, ET AL.	:	
	:	Group Art Unit: 2811
Application No.: 10/657,269)	
	:	
Filed: September 9, 2003)	
	:	
For: SEMICONDUCTOR DEVICE,)	
METHOD FOR	:	
MANUFACTURING THE SAME,)	
AND LIQUID JET APPARATUS	:	April 13, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents, together with English-language translations, are enclosed.

The listed documents were previously cited in the Information Disclosure Statement dated September 8, 2003. However, these documents are being cited again here, since English-language translations are now being provided.

The Examiner's attention is also directed to the following document:

Korean Office Action dated January 28, 2004, in KR-2001-0086492.

The Korean Office Action issued in a Korean application corresponding to the subject application. The Korean Office Action cites the documents listed on the Form PTO-1449. Since a copy of the Korean Office Action was submitted with the Letter filed March 8, 2004, a copy is not being provided here.

Applicants submit that the Korean Office Action can be summarized as follows:

Japan 62-98764 discloses a method of manufacturing a CMOS type semiconductor device, and Japan 8-97410 discloses a method of manufacturing a self-aligned lateral D-MOS transistor.

FORMAL MATTERS

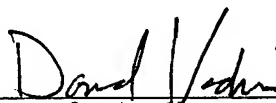
In accordance with 37 C.F.R. § 1.97(b), since a first Office Action on the merits of the subject application has not yet been issued, neither a statement under 37 C.F.R. § 1.97(e) nor payment of a fee is believed to be required for consideration of this Information Disclosure Statement. However, the Commissioner is hereby authorized to charge any fee which may be required in connection with this paper to Deposit Account No. 06-1205. A duplicate of this paper is enclosed for that purpose.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants
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FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) Date Submitted to PTO: April 13, 2004				ATTY DOCKET NO. 03500.016072.1		APPLICATION NO. 10/657,269	
				APPLICANT MINEO SHIMOTSUSA, ET AL.			
				FILING DATE September 9, 2003		GROUP 2811	

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT	
	62-98764	05/08/1997	Japan			Yes	
	8-97410	04/12/1996	Japan			Yes	

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)		

EXAMINER	DATE CONSIDERED
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.